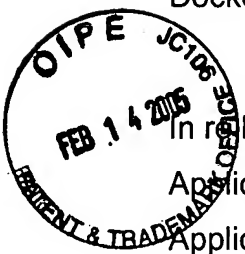


IFW

Docket No. EATNP139US

02-IMP-037



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re **PATENT** application of:

Applicant: Victor M. Benveniste

Application No.: 10/669,186

For: ION BEAM SLIT EXTRACTION WITH MASS SEPARATION

Filing Date: September 24, 2003

Examiner: Kalimah Fernandez

Art Unit: 2881

**REPLY TO OFFICE ACTION DATED FEBRUARY 8, 2005**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.